Form 1449 (Modified)

Atty Docket No. Application No.: SYMXP001 09/691,421

**Information Disclosure Statement By Applicant**  Inventor

Xiao Ping Zhou et al.

Group

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(Use Several Sheets if Necessary)

Filing Date

October 1'

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Form 1449 (Modified)

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Application No.:

Inventor

SYMXP001 09/691,421

Xiao Ping Zhou et al.

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